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Optimized THz photoconductive devices based on low-temperature grown III-V compound semiconductors incorporating distributed Bragg reflectors

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Abstract: This paper reports work on optimized THz photoconductive antenna switches based on low temperature grown materials incorporating distributed Bragg reflectors (DBRs). These materials were characterised electrically using Hall Effect, mid-infrared reflectivity measurements and fabricated antennas tested under pulsed excitation in a time domain spectroscopy (TDS) system. It is shown that the inclusion of DBR results in enhanced THz peak signals by more than twice across the entire operating frequency range. In addition, the devices exhibit significant improvements in the relative THz power, responsivity and optical to electrical efficiency compared to the reference ones.

1. Introduction

Nowadays, one of the most widely used methods for generating THz electromagnetic radiation for THz time domain spectroscopy (TDS) and THz two-dimensional imaging applications is through photoconductive antennas [1-4]. In addition, the most promising photoconductive material is low temperature grown GaAs (LT-GaAs) [5]. By using the molecular beam epitaxy (MBE) technique, deep energy levels in the middle of the energy band gap of the semiconductor arise from the formation of point defects during the growth at low temperature, i.e. $\leq 250^\circ\text{C}$ and the subsequent precipitation of excess arsenic presents in the material [6]. In this particular case, the LT-GaAs meets all the requirements of photoconductive materials [7, 8]. At room temperature, the band gap of LT-GaAs is 1.42eV, which needs a femtosecond laser operating at 800nm to excite it. However, this type of laser, such as Ti-Sapphire, is costly and bulky. In order to build a low cost but still comparable TDS system, alternative materials which have smaller band gaps and that are suitable for use with lasers operating at longer wavelengths (most desired versions are at the 1550nm telecommunication wavelength) are required [9, 10]. THz TDS systems operating at 1550nm based on LT-InGaAs photoconductive antennas have been built and evaluated in [11-14]. LT-In_{0.53}Ga_{0.47}As-In_{0.52}Al_{0.48}As which can be operated at 1550nm has been reported to show a good response in TDS systems, but the obtained output THz power still does not reach level comparable to that of LT-GaAs [15].

By using distributed Bragg reflectors (DBRs), a resonant-optical-cavity photoconductive switch had been reported with significant improvement in performance at 300GHz [16]. In conventional material systems, the active layers (low temperature grown layers) can absorb only small part of the incident pump laser power and thus the inclusion of DBR layers can reflect most of the unabsorbed radiation back toward the active layers where it has the correct phase to destructively interfere with the residual reflection of the incident beam. In this paper, we report a series of planar aperture and dipole antenna structures fabricated on low temperature grown GaAs and InGaAs-InAlAs (on InP) photoconductors incorporating DBRs. The materials were characterised by performing Hall Effect, mid-infrared reflectivity, and the fabricated devices were evaluated in a TDS system. We demonstrate that this design further improves devices performance in the TDS system with respect to already efficient devices based on III-V semiconductor compounds we reported recently [17].

2. Sample Descriptions

The materials used in the photoconductive emitters and detectors are similar to those reported previously for photo-excited THz photoconductors [18, 19]. All materials used in this study were grown in a RIBER V100 system using the low temperature MBE growth technique. The active layers for XMBE305 (sample A) and XMBE290 (sample C) were synthesized to absorb light at wavelengths of 800nm and 1550nm respectively. The optimized samples with DBR layers labelled as XMBE316 (sample B) and XMBE329 (sample D) were also designed to reflect light at the same wavelengths as XMBE305 and XMBE290. Sample A (LT-GaAs grown to operate at 800nm excitation wavelength) was grown on a semi-insulating GaAs (SI-GaAs) substrate and consisted of a 240nm GaAs buffer layer followed by a 50nm AlAs layer and a 1 μ m thickness low temperature grown GaAs layer. The optimized LT-GaAs (sample B) wafer had the same thickness of low temperature grown GaAs layer, but an additional 8 pairs of AlAs/GaAs DBR layers were inserted below the low temperature grown GaAs and above a 100nm GaAs buffer layer. The total thickness of the DBRs was 1.03 μ m. In the case of sample C, the LT-In_{0.53}Ga_{0.47}As-In_{0.52}Al_{0.48}As multi-quantum wells (MQWs) structures, which were synthesised to operate at 1550nm, were grown on SI-InP substrates, above a 90nm InAlAs buffer layer. The active layers of these samples consist of 50 periods of 12nm In_{0.53}Ga_{0.47} and 9nm In_{0.52}Al_{0.48}As super-lattice structure and an In_{0.53}Ga_{0.47} cap layer which were also grown at low temperature. All active layers were uniformly doped with Be atoms with a doping concentration of $2 \times 10^{18} \text{ cm}^{-3}$. The optimized LT-InGaAs/InAlAs (sample D) wafer contained 50 periods of 12nm InGaAs and 12nm InAlAs super-lattice structure with the same doping concentration as active layers in sample C. The 8 pairs of InGaAs-InAlAs DBR layers with a total

thickness of 1.65μm were sandwiched by the active layers and InP substrate. The epitaxial layers of all samples investigate in this work are shown in Fig.1.

Fig. 1 Physical structures along with the layer thicknesses
a LT-GaAs (sample A)
b LT-GaAs with DBRs (sample B)
c LT-InGaAs-InAlAs (sample C)
d LT-InGaAs-InAlAs with DBRs (sample D)

In order to improve the electro-optical characteristics of the samples, annealing at specific temperatures (600°C for LT-GaAs and 580°C for LT-InGaAs/InAlAs) was necessary [20]. All samples were annealed for 10 minutes and were covered by high purity SI GaAs substrates to prevent arsenic loss from the sample surface. This post growth annealing was performed using a Rapid Thermal Annealer (RTA) in a nitrogen atmosphere. RTA allowed the formation of precipitates from the excess arsenic incorporated as point defects [19]. To investigate the effect of the DBR layers, materials were fabricated as antennas in the same epitaxial structures (aperture for emitters and dipole for emitters or detectors). The choice of dipole and aperture geometries as antenna structures was based on a previous study [21]. In that study, the radiation efficiencies of resonant dipole antennas and wide-band aperture antennas were compared and found to be adequate in order to characterise the performance of the photoconductor materials. Fig. 2 illustrates the geometries and dimensions of the aperture and dipole antennas. The aperture structures were designed to have 500μm width with a separation (gap) between the electrodes of

400 μm . The dipole antennas had 20 μm arm's length and the gap between the two arms was 5 μm . All the antenna structures were fabricated on top of the photoconductive materials by standard i-line photolithography techniques. Both AuGe based alloys and Ti/Au metals are usually used as the contacts for photoconductive THz antennas[22-24], Ti/Au deposition was chosen in this work to define the antenna region of the photoconductors. After the metallization step, the samples were sintered at 250 °C to enable good adhesion of the contacts.

Fig. 2 Antenna structures designed for THz emitters and detectors
a aperture geometry
b dipole geometry

3. Material Characterisations

3.1. Transport properties

The transport properties of the samples were studied using Hall Effect measurements. The measurements were performed at room temperature on Van Der Pauw structures using a customised set-up consisting of a Keithley current and voltage source measuring units and permanent magnets. Cloverleaf geometries were patterned using standard photolithography technique and wet etching methods with four pieces of Indium (In) alloys used to form the Ohmic contacts.

Both samples A and B were annealed at 600°C. Sample A exhibited a mobility of 2400 cm^2/Vs , carrier concentration of $2.8 \times 10^6 \text{cm}^{-2}$, and a resultant sheet resistance of $9.3 \times 10^8 \Omega/\text{sq}$ [18]. Sample B exhibited a mobility of 2200 cm^2/Vs , carrier concentration of $2.9 \times 10^6 \text{cm}^{-2}$, and a sheet resistance of $9.7 \times 10^8 \Omega/\text{sq}$. Both samples C and D were annealed at 580°C. Because of the high Be-doping throughout the active layers and the less than optimal compensation of the n-type defects in the LT-InGaAs, the mobilities

were much lower at $425\text{cm}^2/\text{Vs}$ [15] and $410\text{cm}^2/\text{Vs}$ for samples C and D respectively. The carrier concentrations were $2.0 \times 10^9\text{cm}^{-2}$ and $1.9 \times 10^9\text{cm}^{-2}$ for samples C and D. The corresponding sheet resistances of samples C and D were $7.2 \times 10^6\Omega/\text{sq}$ and $7.9 \times 10^6\Omega/\text{sq}$ respectively. Samples C and D exhibited one order of magnitude higher sheet resistance than the best LT- InGaAs-InAlAs reported in the literature [17].

According to the data shown above, the transport properties of the normal samples and their DBR counterparts are comparable, thus a conclusion can be reached that the DBR layers do not affect the electrical performance of the active layers.

3.2. Mid-Infrared Reflectivity Measurements

In order to study the optical effect of the DBR layers, reflection measurements were carried out at room temperature using an Ocean Optics LS1 tungsten halogen light source. The detector for the LT-InGaAs-InAlAs structures was an Ocean Optics NIR256-2, while an Ocean Optics S2000 CCD detector was used for the LT-GaAs devices. Sample B was split into three pieces (As grown, B1 and B2) and prepared using a wet etching method. Samples were etched to two different depths. The first one terminated marginally above the DBR layers while the second was etched into the DBR layers. The depths of sample B1 and B2 were 960nm and 1020nm respectively. Sample D was prepared in a similar manner providing depths of 1070nm and 1270nm for sample D1 and D2 respectively. In order to obtain a direct response of the DBRs, the reflectance measurements were normalised using the as grown samples (B and D). The measured results are shown in Fig. 3 (a) and (b).

Fig. 3 Normalised reflectivity
a LT-GaAs samples with DBRs: B1(black solid line) and B2 (red dash line)
b LT-InGaAs/InAlAs samples with DBRs: D1(black solid line) and D2 (red dash line)

The black solid line in Fig. 3 can be considered as the contribution that includes the response of both the active and DBR layers. Since the as grown sample was used as the reference and compared with the etched sample (which had a majority of its active layers removed), the normalised reflectivity is shown to be higher than the reference at all wavelengths. This is a consequence of the active layers absorbing more radiation in the reference sample and this is more evident with increasing etch depth (red dash lines in Fig. 3). The highest normalised reflectivity is approximately twice the as grown reference sample obtained at 800nm for sample B.

4. Antenna Characterisation

The fabricated antennas were evaluated as emitters and detectors in a TDS system under pulsed operations at room temperature in an un-purged environment. In this setup, a Mai Tai pulse laser from Spectra Physics operating at 800nm wavelengths was used for samples A and B, and a FemtoFiber FFS short pulse laser from Toptica Photonics AG operation at 1550nm was used for sample D. A beam splitter was used to separate the output pulse from the laser source into the pump beam and the probe beam. The pump beam was focused onto the surface of the emitter while the probe beam was delayed and focused onto the detector. High resistivity hyper-hemispherical Si lenses were attached at the back side of the antennas in order to collimate and focus the THz radiation. In the 1550nm operation system, the laser beam can be easily coupled to the photoconductive antenna by using optical fibers thus making the system compact and portable. In the case of 800nm operating system, the optical pulse duration was 100fs, the pulse repetition rate was 80MHz while the pump and the probe beam average power were 25mW and 10mW respectively. In the case of 1550nm system, the optical pulse duration was 100fs, and the pulse repetition rate was 86MHz while the pump and the probe beam average powers were 14.5mW and 14mW respectively.

4.1. LT-GaAs Antennas

To investigate the photoconductor antenna with DBRs, two tests were performed. The first set of measurement used sample A as the emitter while the second one used sample B as the emitter. Throughout the measurements, emitters with 400µm gap were under a bias of 50V and the reference receiver device was a dipole antenna fabricated on material XMBE305 (sample A). Fig.4 depicts the comparison of emitted THz pulses and Fourier power spectrums using samples with and without DBRs as emitter (the sample without DBRs was used as detector for both measurements).

Fig. 4 Devices evaluation in the TDS system at 800nm pulse excitation

a THz pulses generated from aperture antennas made on sample A ((LT-GaAs: blue line) and sample B (LT-GaAs with DBRs: red line) and detected by dipole antenna made on sample A

b normalized Fourier transform power spectrums emitted from aperture antennas made on sample A (LT-GaAs: blue line) and sample B (LT-GaAs with DBRs: red line) and detected by a dipole antenna made on the sample A

The full width half maximum (FWHM) was 0.533ps indicating a reasonably fast switching speed of the photoconductor. The 20dB bandwidth using sample B as emitter indicated a spectral extent of 1.44THz and the dynamic range extended up to 3.5THz with power to noise ratio of more than 60dB (noise floor). When sample A was used as emitter, the FWHM was 0.55ps, and the 20dB bandwidth was 1.32THz with a 4THz for 60dB noise floor. The THz peak signal from sample B is 11.5 nA, this is more than twice that of the peak signal without DBRs. By taking into account the incident THz electric field and the measured current, the relative THz power of the emitter can be estimated in arbitrary units. Therefore, the relative magnitudes of the THz power of sample A and B are 2050 and 6900, with responsivities of 0.57nA/mW and 1.15nA/mW respectively. The optical to electrical efficiency of the sample was determined by the photoconductive power and pump power, the results of samples A and B were 1.47% and 3.6% respectively. Thus, in comparing samples A and B, we conclude that the DBRs under LT-GaAs does not affect the switching speed but rather results in enhancing the THz peak signal, the relative magnitude of the THz power, and the optical to electrical efficiency by more than twice as well increasing the transmitter photocurrent.

4.2. LT-InGaAs-InAlAs MQWs Antennas

In the case of the LT-InGaAs-InAlAs MQWs samples, the measurement set up was similar to LT-GaAs. Sample D was fabricated into a dipole antenna for both emission and detection and the emitter was bias at 3V.

Fig. 5 Devices evaluation in the TDS system at 1.55 μm pulse excitation

a THz pulse generated and detected by dipole antennas made on sample D (LT-InGaAs with DBRs)

b normalized Fourier transform power spectrum emitted and detected by dipole antennas made on sample D (LT-InGaAs with DBRs)

The LT-InGaAs-InAlAs MQWs sample had already been evaluated and reported in [15, 19]. The photoconductive switching speed of sample D was not as fast as reported in our previous report and the bandwidth was also narrower. These results indicate a poor bandwidth compared to previous systems reported by our group or compared to commercial available systems. This can be explained by the doping profile used (uniform doping throughout the active layers) and also due to the antenna geometry chosen. Nevertheless, with the inclusion of the DBRs, the relative magnitude of the THz power of sample D was 57 with a responsivity of 0.086 nA/mW, compared with similar material systems [15] that showed relative magnitude of the THz power of 0.83 and a responsivity of 0.008 nA/mW. These results show clearly the importance of the incorporation of DBR layers in increasing the optical to electrical efficiency of sample D which rose to 1.14%, and is approximately double the efficiency of similar material system.

5. Conclusions

This work reports on a systematic study showing enhanced and excellent performance of photoconductive switches integrated with DBR layers in GaAs and InGaAs-InAlAs technologies. The designed materials can be fabricated as THz emitters and detectors operating at room temperature at both 800 nm and telecom communication wavelength of 1550 nm. The DBRs result in a marked enhancement of the THz peak signal by more than twice, an increase of the transmitter photocurrent and a doubling of the optical to electrical efficiency. By coupling DBRs with active layers, the performances of photoconductive switches show better responses and further allow for higher quality THz measurements to be made.

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